



AF/2815

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Zhiping Yin et al.

Title: OXYGEN PLASMA TREATMENT FOR NITRIDE SURFACE TO REDUCE PHOTO FOOTING

Docket No.: 303.531US1

Serial No.: 09/259762

Filed: March 1, 1999

Due Date: June 10, 2003

Examiner: Jose Diaz

Group Art Unit: 2815

MS AF

Commissioner for Patents

P.O.Box 1450

Alexandria, VA 22313-1450

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CERTIFICATE UNDER 37 CFR 1.8: The undersigned hereby certifies that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail, in an envelope addressed to: MS AF, Commissioner for Patents, P.O.Box 1450, Alexandria, VA 22313-1450, on this 17 day of May, 2003.

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